As a below named inventor, I hereby declare:

That my residence, post office address and citizenship are as stated below next to my name.

That I verily believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

## METAL-ASSISTED CHEMICAL ETCH POROUS SILICON FORMATION METHOD

the specification of wh  ( ) is attached here					
, , ,					
and was amended on		<del></del>			
	(if applicable)				
amendment referred to		itents of the above-identified s	pecification, includin	ng the claims, as amended	l by any
That I acknowle Title 37, Code of Fede	dge the duty to disclose inforal Regulations, §1.56(a).	rmation known to be material t	o patentability of this	s application in accordan	ice with
inventor's certificate li	sted below and have also ic	under Title 35, United States C lentified below any foreign ap plication on which priority is o	plication for patent	eign application(s) for p or inventor's certificate	atent or on this
Prior Foreign Applic	ation(s)			Priority Claimed	d
Number)				( ) ( ) Yes No	
(Number)	(Country)	(Day/Month/Yea	ar Filed)		
Number)				()()	
				Yes No	
(Number)	(Country)	(Day/Month/Yea	ar Filed)		
				( ) ( )	
				Yes No	
(Number)	(Country)	(Day/Month/Yea	ar Filed)		
insofar as the subject m provided by the first p defined in Title 37, Co	atter of each of the claims of aragraph of Title 35, United	35, United States Code, §120 of this application is not disclosed States Code, §112, I acknow §1.56(a) which occurred between the state of the state	ed in the prior United wledge the duty to d	States application in the lisclose material information	manner ation as
United States Applica	ation(s)				
(Application Serial No	.)	(Filing Date)	(Status)-(F	Patented, pending, aband	doned)
(Application Serial No	·.)	(Filing Date)	(Status)-(I	Patented, pending, aband	— doned)
(Application Serial No	<u></u>	(Filing Date)	(Status)-(F	Patented, pending, aband	 doned)

That all statements is therein of my own knowledge are true and that all the pents made on information and belief are believed to be had and further that these statements were made with the howledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

I hereby appoint the following attorneys and agents, with full power of substitution and revocation, to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith and request that all correspondence and telephone calls in respect to this application be directed to GREER, BURNS & CRAIN, LTD., Suite 8660 - Sears Tower, 233 South Wacker Drive, Chicago, Illinois 60606, Telephone No. (312) 993-0080:

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